

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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| Attorney Docket Number | 1011-54375-01 |
| Application Number | 09/620,021 |
| Filing Date | July 20, 2000 |
| First Named Inventor | Rajski |
| Art Unit | 2133 |
| Examiner Name | Phung M. Chung |

U.S. PATENT DOCUMENTS

Copies of U.S. Patent documents do not need to be provided, unless requested by the Patent and Trademark Office. For patents, provide the patent number and the issue date. For published U.S. applications, provide the publication number and the publication date. For unpublished pending patent applications, provide the application number and the filing date.

| Examiner's Initials* | Cite No. (optional) | Number | Issue Date | Name of Applicant or Patentee |
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EXAMINER SIGNATURE: /Phung Chung/

DATE CONSIDERED: 06/19/2008

* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.